

# Temperature Dependence of the Reconstruction of Zig-Zag Edges in Graphene

Kuang He,<sup>1</sup> Alex W. Robertson,<sup>1</sup> Ye Fan,<sup>1</sup> Christopher S. Allen,<sup>1</sup> Yung-Chang Lin,<sup>2</sup> Kazu Suenaga,<sup>2</sup>  
Angus I. Kirkland,<sup>1</sup> Jamie H. Warner<sup>1\*</sup>

<sup>1</sup>Department of Materials, University of Oxford, Parks Road, Oxford, OX1 3PH, UK

<sup>2</sup>Nanotube Research Center, Advanced Institute for Industrial Science and Technology, Tsukuba, Japan

\*[Jamie.Warner@materials.ox.ac.uk](mailto:Jamie.Warner@materials.ox.ac.uk)

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## Abstract

We examine the temperature dependence of graphene edge terminations at the atomic scale using an *in situ* heating holder within an aberration corrected transmission electron microscope. The relative ratio of armchair, zig-zag and reconstructed zig-zag edges from over 350 frames at each temperature are measured. Below 400°C, the edges are dominated by zig-zag terminations, but above 600°C this changes dramatically, with edges dominated by armchair and reconstructed zig-zag edges. We show that at low temperature chemical etching effects dominate and cause deviation to the thermodynamics of the system. At high temperatures (600 and 800 °C) adsorbates are evaporated from the surface of graphene and chemical etching effects are significantly reduced, enabling the thermodynamic distribution of edge types to be observed. The growth rate of holes at high temperature is also shown to be slower than at room temperature, indicative of the reduced chemical etching process. These results provide important insights into the role of chemical etching effects in the hole formation, edge sputtering and edge reconstruction in graphene.

The structure of edges in graphene has a great influence in its mesoscopic properties.<sup>1-7</sup> Nano-constraint structures in graphene such as nanoribbons,<sup>8,9</sup> quantum dots,<sup>10</sup> and nano-junctions<sup>11-13</sup> are largely influenced by the edge configurations due to the high edge/bulk ratio. Experimental studies of graphene edges typically use either scanning tunnelling microscopy,<sup>9,14-17</sup> aberration corrected transmission electron microscopy (AC-TEM)<sup>18-21</sup> or micro-Raman spectroscopy.<sup>22,23</sup> Despite the abundant studies and structural characterization carried out on the geometry of edge structures, being able to control the edge termination freely still remains a challenging topic. Most top-down production techniques such as electron and photo- lithography, unzipping of carbon nanotubes and metal particle assisted etching result in defective graphene edges.<sup>8,24-27</sup> Anisotropic etching of graphene with the assistance of metal nanoparticles and hydrogen at elevated temperatures has been reported recently to produce predominately zig-zag edges,<sup>28,29</sup> but characterization of these edges at the atomic scale is lacking. Whilst graphene edges might appear regular at the micrometre scale, often closer examination at the detailed atomic level reveals more complex edge terminations that are not fully periodic.<sup>30,31</sup> Tearing graphene has shown to be one approach for achieving long periodic edge structures.<sup>33</sup>

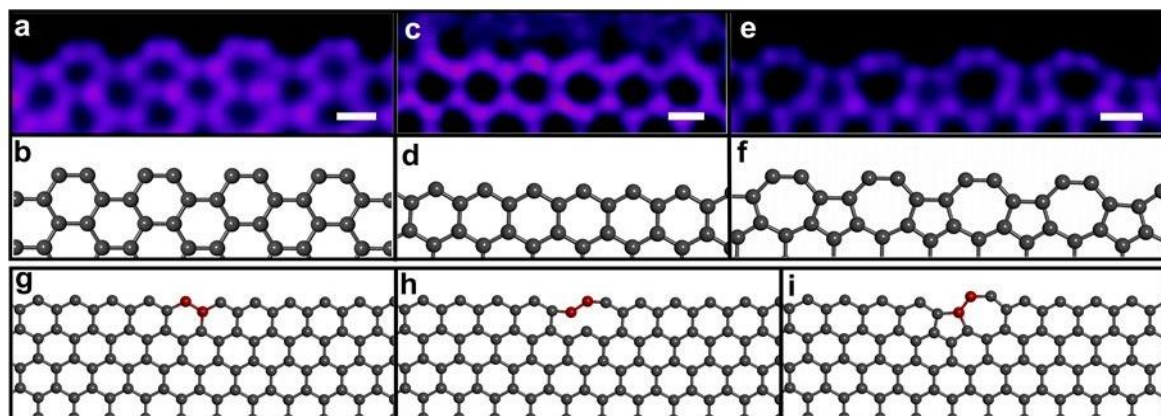
The three main periodic edge terminations of graphene are presented in Figure 1. The armchair configuration shown in figure 1(a,b) and the zig-zag configuration shown in figure 1(c,d) have long been recognised as the intrinsic edges of graphene. Both types can also reconstruct into different geometries. For example, zig-zag edges are known to reconstruct into a pentagon-heptagon structure (namely Rec. 5-7 edges) through a series of bond rotations, shown in figure 1(e,f), to lower its energy.<sup>32-34</sup> There is no atom loss involved with this process, as can be seen from figure 1(g-i), one C-C bond rotates 90° and rebonds to the nearest atom after rotation. This is similar to the Stone-Wales bond rotation in the bulk of graphene.<sup>35</sup> Armchair edges have two reconstructed forms, a hexagon-heptagon-heptagon structure (namely ac(677)) and a pentagon-hexagon structure (namely ac(56)).<sup>36</sup> Both of which, according to computational results, have higher energy than the original un-reconstructed form and, for that reason, no long ordered structures of these configurations have been observed experimentally, they only appear as isolated incidents on an occasional basis.<sup>32,34,36</sup>

Koskinen *et al.* studied the theoretical geometry and energy of graphene edges and predicted that Armchair, zig-zag and Rec. 5-7 have edge energies of 2.09, 3.22, 2.36 eV/atom respectively.<sup>35</sup> A recent report showed that under electron beam irradiation at an accelerating voltage of 300 kV and at high temperatures of 700 °C, armchair edges became the major edge termination of graphene.<sup>37</sup> A similar result was observed by Joule heating a graphene sample to even higher temperatures using an *in situ* electrical holder inside an AC-TEM at a lower accelerating voltage of 80 kV.<sup>41</sup> However, not much attention has been paid to the fine details of the temperature dependence of zig-zag edges. In particular, determining the cross-over temperature where the low-energy Rec. 5-7 edge dominates over the zig-zag edge. At room temperature zig-zag edges are far more prevalent than Rec. 5-7 edge when being observed using AC-TEM and this was attributed to their higher stability under electron beam irradiation.<sup>19</sup> Even though the Rec. 5-7 edge has lower energy than the zig-zag edge, a small energy barrier must be overcome for this transition to occur, in the same way a Stone-Wales bond rotation requires overcoming an energy barrier. A single Stone-Wales rotation within a bulk graphene sheet was estimated to have a formation energy of 5.08 eV, after overcoming the initial ~10 eV barrier.<sup>38</sup> At the edge, this is reduced to ~1.1 eV because one of the atoms involved with the rotation is only bonded to two other atoms, therefore less bonds need to be broken.<sup>33</sup> At a certain temperature, the thermal energy provided to the system might be large enough to overcome this lower barrier of bond rotation at the edge and this would then result in the zig-zag edge flipping to its Rec. 5-7 form. Density functional tight binding (DFTB) calculation predicts that under 80 keV electron beam sputtering, armchair structure has the highest radiation stability, followed by Rec. 5-7 and zig-zag configuration.<sup>39</sup> Residual contamination, such as amorphous carbon, metal particles are known to remain on the surface of graphene from the synthesis and transfer process. Heating of the sample would dissipate the contamination and prevent the chemical etching effect under continuous electron beam irradiation-revealing the accurate graphene edge behaviour under electron beam.

## Results/Discussion

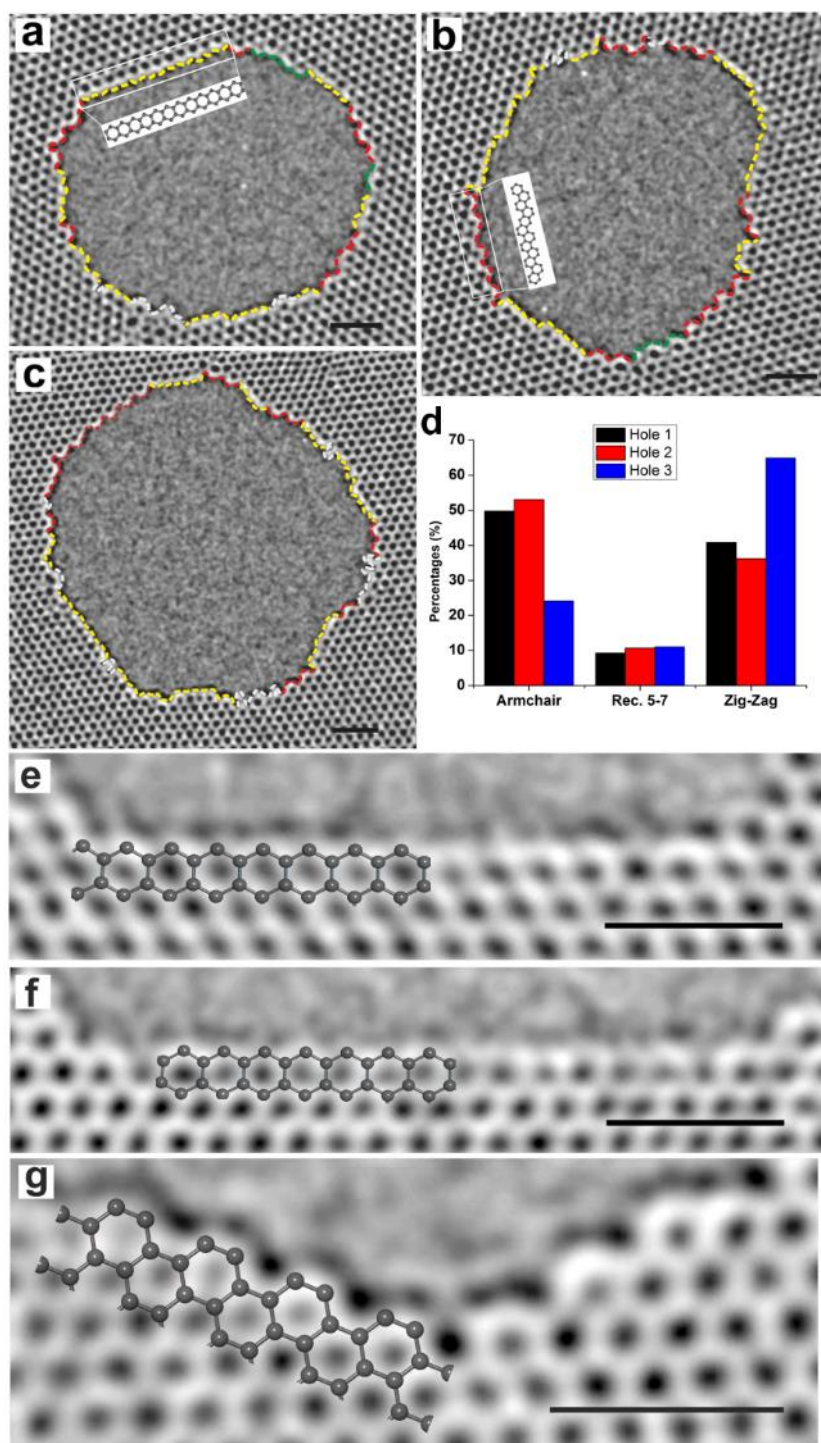
Here, we explore this by adjusting the temperature of graphene in steps from room temperature to 800 °C using an *in situ* heating holder within an aberration-corrected TEM. Atomic

resolution images of the edges of holes in graphene enable us to determine the statistical ratio of the three different edge terminations. The holes are intentionally created in graphene using a controlled focused electron beam sputtering method. This approach for hole creation is well established and has been previously been reported.<sup>40</sup> We allowed the holes to grow in size until they reached at least 15nm in size to ensure individual edge lengths around the hole were long enough to have statistical meaning.



**Figure 1. Three periodic edge terminations of graphene.** (a) AC-Scanning TEM (AC-STEM) image of an armchair edge and (b) its atomic model. (c) AC-TEM image of a zig-zag edge and (d) its atomic model. (e) AC-STEM image of a Reconstructed 5-7 edge and (f) its atomic model. (g)-(i) Schematic illustration showing the reconstruction process from zig-zag to Rec. 5-7 edge, atoms highlighted in red are the rotated atoms. All scale bars are 0.2nm.

Figure 2 shows the results at room temperature ( $\sim 25^{\circ}\text{C}$ ). Figures 2(a)-2(c) are three different representative holes, the edges being colour coded according to different edge terminations. The insets in figure 2(a) and figure 2(b) provide atomic models of the zig-zag and armchair edges observed in these regions. The room temperature statistics, figure 2(d), for all three time series for different holes show that  $\sim 45\%$  are zig-zag,  $\sim 40\%$  are armchair and  $\sim 10\%$  are Rec. 5-7. Typical long ordered zig-zag edges are shown in figure 2(e) and figure 2(f) respectively and a long ordered armchair edge in figure 2(g).

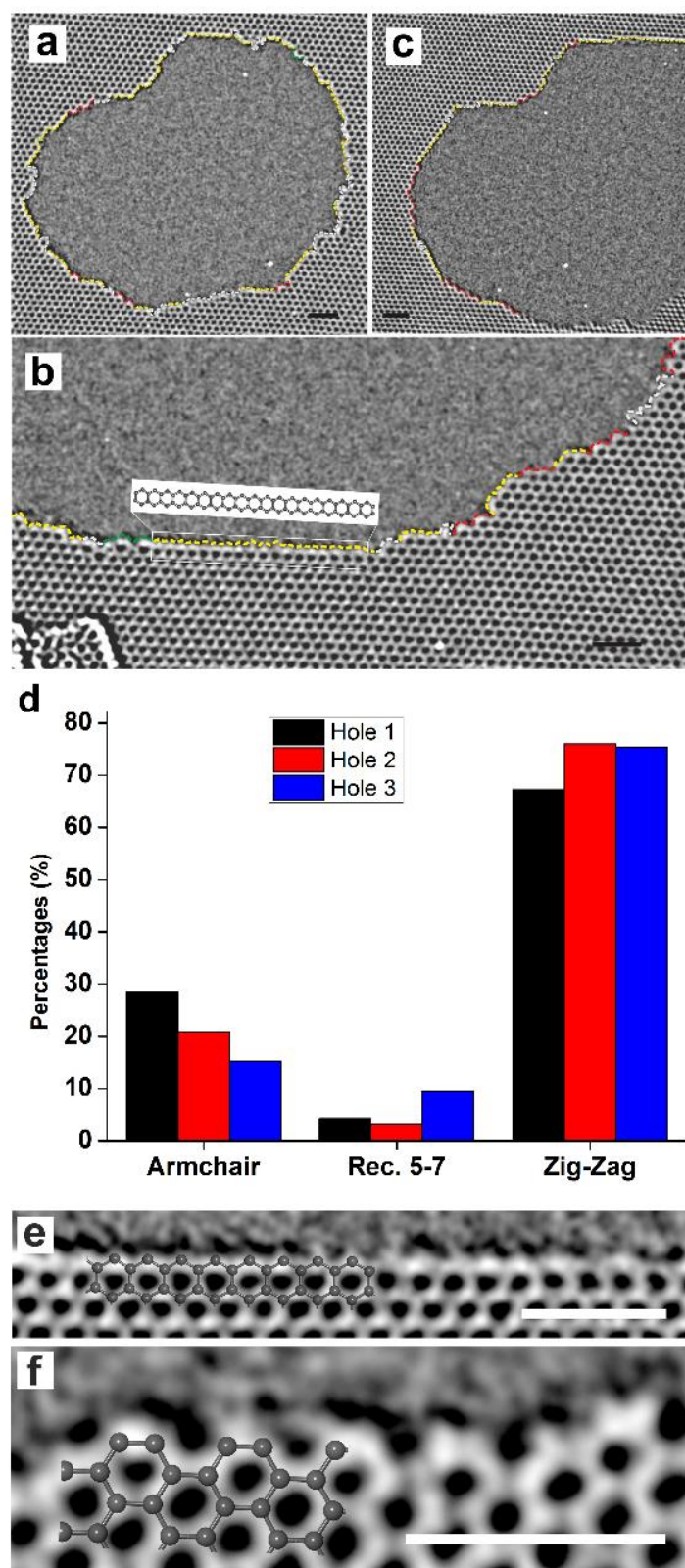


**Figure 2. Edge behaviour at room temperature (~25°C)** (a-c) are three typical HRTEM images of graphene holes at that temperature. The edges are colour coded to differentiate the types of edge configurations. Red represents Armchair, yellow is zig-zag and green is Reconstructed 5-7; white indicates mixed or unidentified edge types. The inset in (a) and (b) shows typical long order zig-zag and armchair configurations at this temperature. The statistics for three examples are shown in (d); the percentages of edges occupied by different types of edges are ranked accordingly, black columns represent panel (a), red columns panel (b) and blue columns panel (c). (e) and (f) are long ordered zig-zag edge from both bulk of graphene

and edge of an nano-ribbon respectively. Panel (g) is a representative long ordered armchair edge found at this temperature. The original image of which (e), (f) and (g) are cropped from are shown in Figure S1 (a)-(c) of supporting information. All scale bars are 1nm.

Increasing the temperature to 400°C didn't change the distribution of edge terminations significantly, as shown in figure 3. Three typical holes are shown in Figure 3 (a-c), together with the statistics for three time series of different holes shown in figure 3(d). Zig-zag edges still form ~70%, armchair ~20%, and Rec. 5-7 < 5%. Figure 3(e) shows a typical long ordered zig-zag structure and again is generally longer than the armchair edges shown in figure 3(f). This shows that the edge structure of graphene at 400 °C is similar to that at 25 °C.



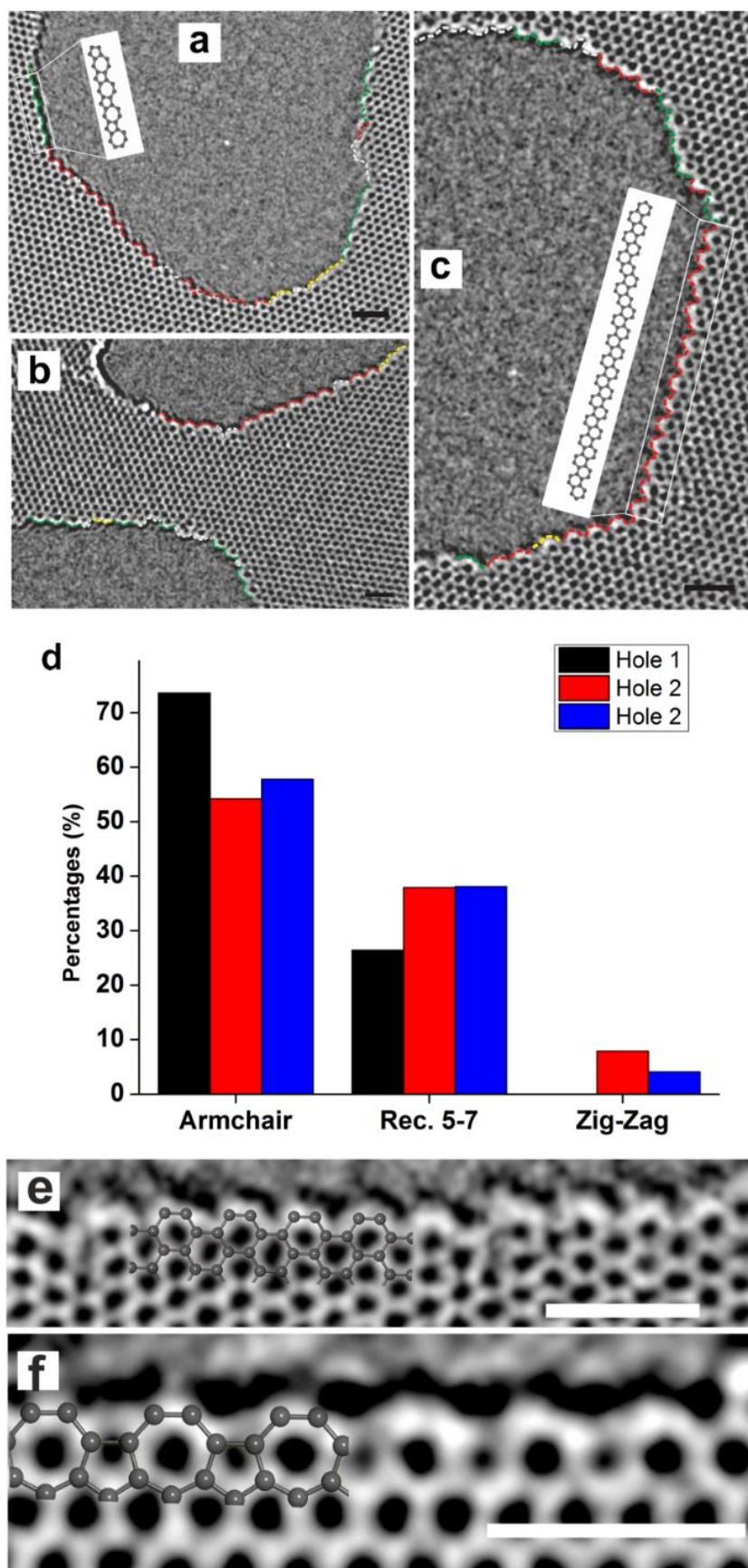


**Figure 3. Edge behaviour at 400°C.** (a-c) are three typical HRTEM images of graphene holes at this temperature. The edges are colour coded to differentiate the types of edge configurations. Red represents armchair, yellow is zig-zag and green is Rec. 5-7, while white indicates mixed or unidentified edge types. The inset in (c) shows that a typical long order zig-zag configuration occurred at this temperature. The statistics for three examples are shown in panel (d); the percentages of edges occupied by different types of edges are

ranked accordingly, black columns represent panel (a), red columns panel (b) and blue columns panel (c). (e) is a representative long ordered zig-zag edge cropped from panel (c) and zoomed in. (f) is an representative long ordered armchair edge cropped from Panel (b) and zoomed in. All scale bars are 1 nm.

Increasing the temperature to 600 °C resulted in a drastically different distribution of edge terminations, shown in figure 4. Armchair edges now account for ~60%, zig-zag <5% and Rec. 5-7 30-40%. The major change is the large decrease in the percentage of zig-zag edges at the expense of a rise in Rec. 5-7 edges. The inset of figure 4 (a), shows the long ordered Rec. 5-7 edges and the inset of figure 4(c) shows the long ordered armchair edge. No long ordered zig-zag edge structure was observed. A typical long ordered armchair structure is shown in higher magnification in figure 4(e), and the length is longer than those obtained at room temperature and 400°C. Long ordered Rec. 5-7 structures, such as those seen figure 4(f), start to appear more frequently. Observation of edge structures are carried out at various time period after temperature elevation, ranging from 10 minutes to overnight heating. The surface adsorbates are found to be evaporated immediately and no significant change of the adsorbates density in terms of heating time was observed. The edge structure was also found to be independent of heating time – the edge configurations do not experience significant change after overnight heating.

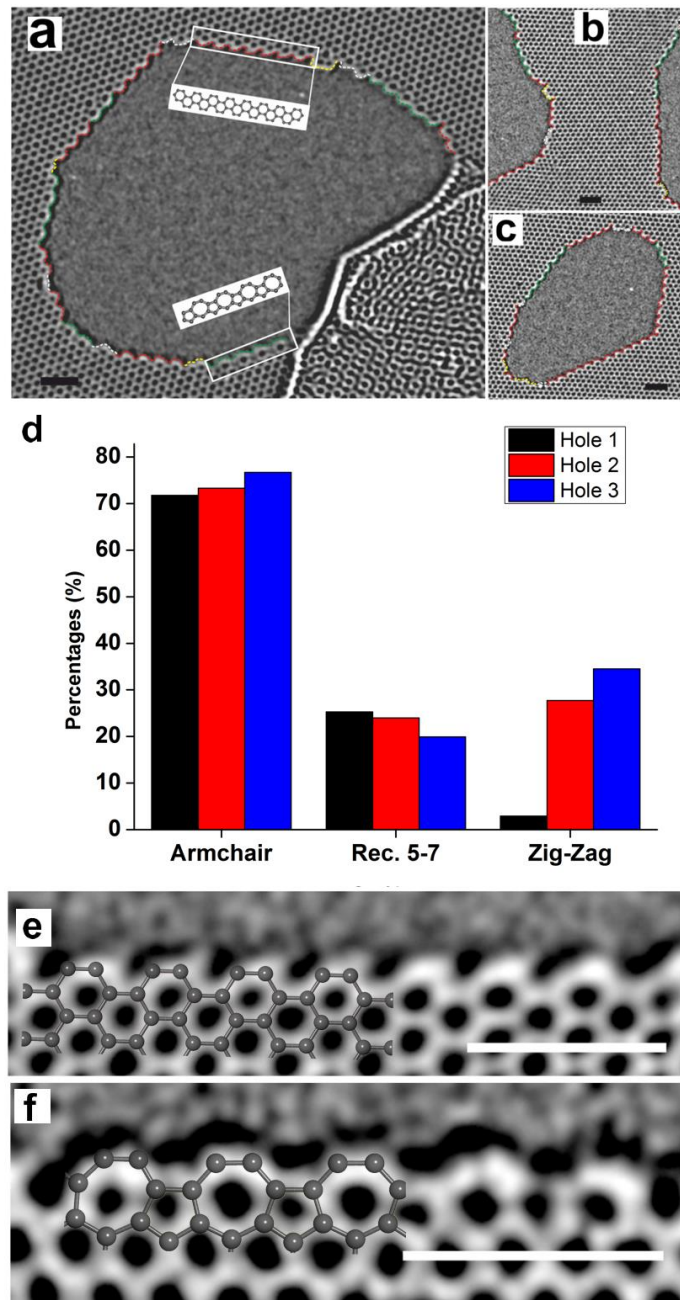




**Figure 4. Edge behaviors at 600 °C.** (a-c) are three typical HRTEM images of graphene holes at this temperature. The edges are colour coded to differentiate the types of edge configurations. Red represents armchair, yellow is zig-zag and green is rec. 5-7; while white indicates mixed or unidentified edge types. The

inset in (a) and (c) shows that typical long order reconstructed 5-7 and armchair configurations at this temperature. The statistics for three examples are shown in (d); the percentages of edges occupied by different types of edges are ranked accordingly, black columns represent panel (a), red columns panel (b) and blue columns panel (c). (e) is a representative long ordered armchair edge cropped from panel (c) and zoomed in. (f) is an representative long ordered Rec. 5-7 edge cropped from panel (a) and zoomed in. All scale bars are 1nm.

Finally we increased the temperature to 800°C to examine if any further changes occurred to the distribution of edge types, shown in figure 5. Along the long armchair edge on the upper left corner of Figure 5(a), a 7-5-7 edge structure occurred among it, and along the same direction as the armchair edge. This occurs from reconstruction of a near edge defect, instead of zig-zag reconstruction. This type of reconstruction is short range and is not likely to affect the overall statistics. The statistics in figure 5(d) show armchair remains the most predominate edge ~70% followed by Rec. 5-7 edge (20-30%), with zig-zag edge being the least frequently observed edge type (<5%), similar to the case at 600 °C. Figures 5(e) and 5(f) are typical examples of armchair and Rec. 5-7 edges at this temperature. The absence of any further changes in the edge distributions indicates that the region between 400 – 600 °C is the major point of interest.



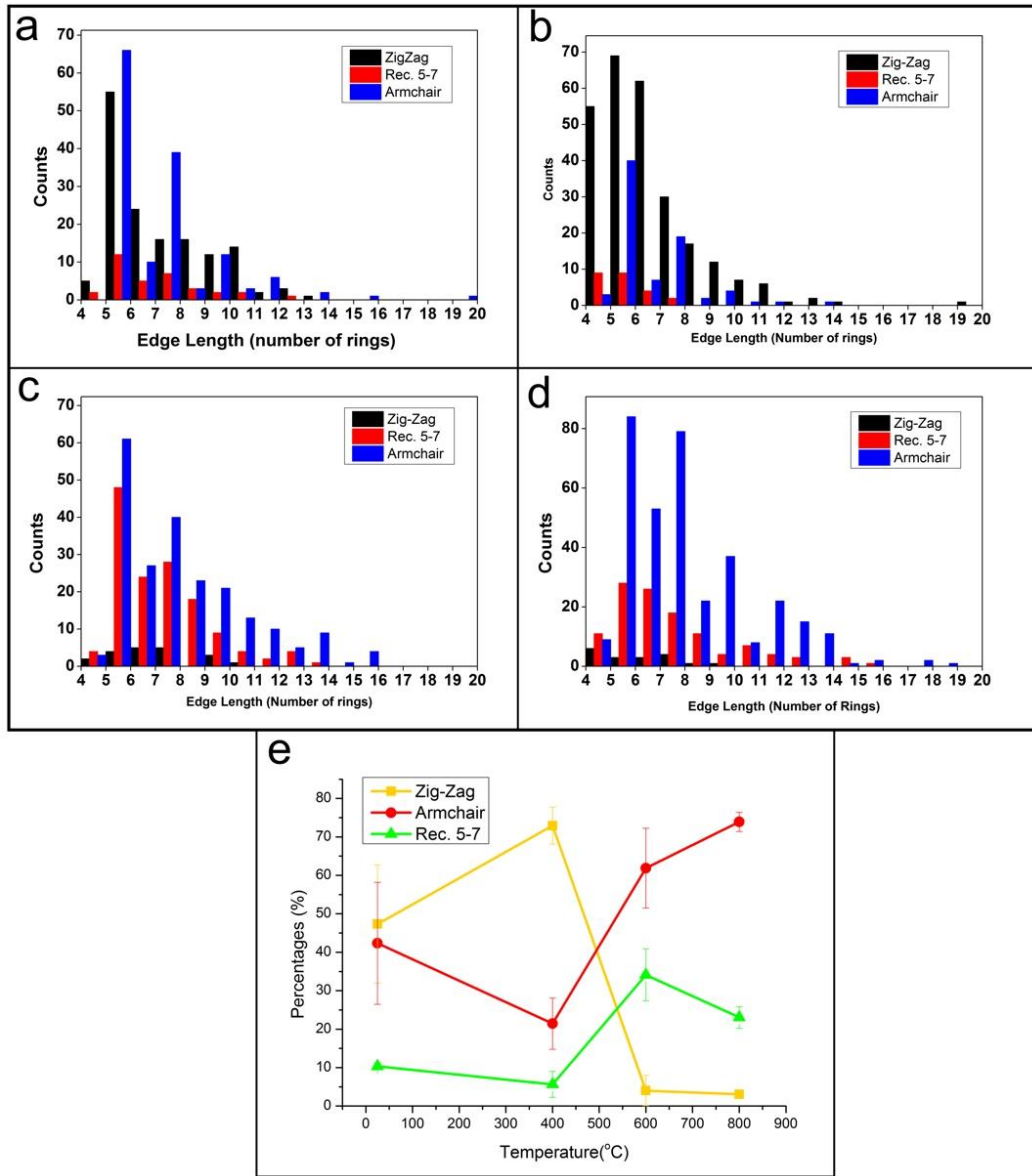
**Figure 5. Edge behaviours at 800°C.** (a-c) are three typical HRTEM images of graphene holes at this temperature. The edges are colour coded to differentiate the types of edge configurations. Red represents armchair, yellow is zig-zag and green is Rec. 5-7; white indicates mixed or unidentified edge types. The inset in (a) shows typical long ordered Rec. 5-7 and armchair configurations at this temperature. The statistics for three examples are shown in panel (d), the percentages of different types of edges are ranked accordingly, black columns represent panel (a), red columns panel (b) and blue columns panel (c). (e) is a representative long ordered armchair edge cropped from panel (c) and zoomed in. (f) is an representative long ordered Rec. 5-7 edge cropped from panel (a) and zoomed in. All scale bars are 1 nm.

More than 350 frames like the ones shown above taken over multiple number of holes (three holes for each temperature) are then used in the statistical analysis of edge type. The results are shown in Figure 6 (a – d) for RT, 400 °C, 600 °C and 800 °C respectively. Only holes with diameters larger than ~15 nm are included in the counting process, to keep the edge strain effect to a minimum. Also, only edges that have 4 rings or longer are considered. The maximum counts occur for the edge length of ~6 rings for all four temperatures, with the counts tailing off towards longer edge lengths. The most perceptible difference between RT, 400 °C (a,b) and, 600 °C, 800 °C (c,d) is the decrease in the number of zig-zag edges and increase in the number of armchair and Rec. 5-7 edges. This is summarised in Figure 6(a), where the temperature dependence of the average population distribution of the three edge types is plotted. It shows the major change lies between 400 – 600 °C, where the edges undergo abrupt transformations: zig-zag edges experienced a reduction from ~60% to ~5%, armchair edges increased from ~30% to ~60% and Rec.5-7 edges increased from ~5% to ~30%. This shows that the temperature between 400-600 °C is the cross over point for zig-zag edges converting to Rec.5-7 edges.

The theoretical formation energy for graphene edge types decreases from zig-zag, armchair to Rec. 5-7.<sup>32,36,41,42</sup> This means the thermodynamic stability should be increasing from zig-zag, armchair to Rec. 5-7. However, within the TEM, edges are irradiated by the electron beam and radiation stability of the edge is extremely important. Calculations indicate the radiation stability of edges reduces from armchair, Rec. 5-7 to zig-zag, which is different to the formation energy.<sup>39</sup> Both armchair and Rec. 5-7 edges have two atoms at the edge that are only bonded to two other atoms, the neighbouring two atoms form a dimer, the kinetic energy provided by the electron collision is distributed between the dimer and occasionally results in a 180° rotation (flipping).<sup>39</sup> The zig-zag edge on the other hand does not allow this kind of rotational reconstruction due to the geometrical restrictions, and is therefore the least stable structure out of the three under electron beam irradiation. Calculations of the sputtering threshold of graphene edges indicate that the edges should be much more stable than current observations reveal.<sup>37</sup> It is therefore suggested that the rapid sputtering rate

at room temperature of graphene holes is due to a chemical etching process, which essentially lowers the energy threshold of atom removal.

The large change between the low temperature (RT and 400 °C) and high temperature (600 and 800 °C) results is related to both electron beam induced sputtering effects and the thermodynamic low energy structure. Graphene is typically covered with surface adsorbates that remain attached until heated to approximately 500°C inside the TEM, when they evaporate off and leave a pristinely clean graphene surface. This also influences the concentration of surface chemical species that dictate the chemical etching process of graphene edges. The growth rate of holes in graphene at both RT and 800 °C is shown in Figure S2 of supporting information. Holes grow twice as fast at RT compared to 800 °C in our experiment, indicating a decrease in the chemical etching effect at high temperature due to the reduced adsorbate concentration on the surface. During the hole fabrication process, the electron beam is contracted down to a 10nm spot to maximise the beam current density and it takes noticeably longer to create a hole using this method at 800 °C (10 min.) compare to RT (3 min.). Supporting the notion that the hole fabrication/growth process at low temperature (below 400 °C) is dominated by chemical etching, activated by large concentration of surface contamination, which might include metal particles, hydrocarbons, and amorphous carbon. The chemical etching effect diminishes as the contamination evaporates off with increasing temperature. The 600°C and 800°C statistics are least effected by chemical etching and reflect the theoretical predictions of edge stability. Long edges are more stable at these high temperatures, illustrated by the larger number of edges with 9-16 rings. The zig-zag edge has previously been reported as a predominant edge at room temperature during TEM studies.<sup>19,43</sup> Armchair edges are reported to be more abundant during current annealing with an effective temperature of 2000K inside the TEM.<sup>37,44</sup> But these data are based on only a couple of frames and small number of statistics. Our study tries to address this issue specifically by studying an extensive data base (~1400 frames) that covers a full range of temperatures up to 800 °C.



**Figure 6. Statistics of edge configurations at various temperatures.** (a - d) Statistics of edge configuration at RT, 400°C, 600°C, and 800°C respectively. The number of occurrences is plotted against the edge length (Number of rings that makes up the edge). (e) The three trend lines represent the temperature dependency of different edge configurations, yellow for zig-zag, red for armchair, and green for reconstructed 5-7. The percentage of each edge type is calculated by dividing the sum of edge length of this type by the total number of edges counted.

Fully understanding the statistics of edge types at different temperatures requires consideration of the dynamics and lifetime of the edge. It is reported that the zig-zag edge reconstructs into the Rec. 5-7 *via* a series of bond rotations driven by electron beam impacts.<sup>33</sup> Prior work showed that graphene torn along the zig-zag direction had an edge termination that was stable against electron beam sputtering for about ~50 frames (65s) and enabled flipping rates from (zig-

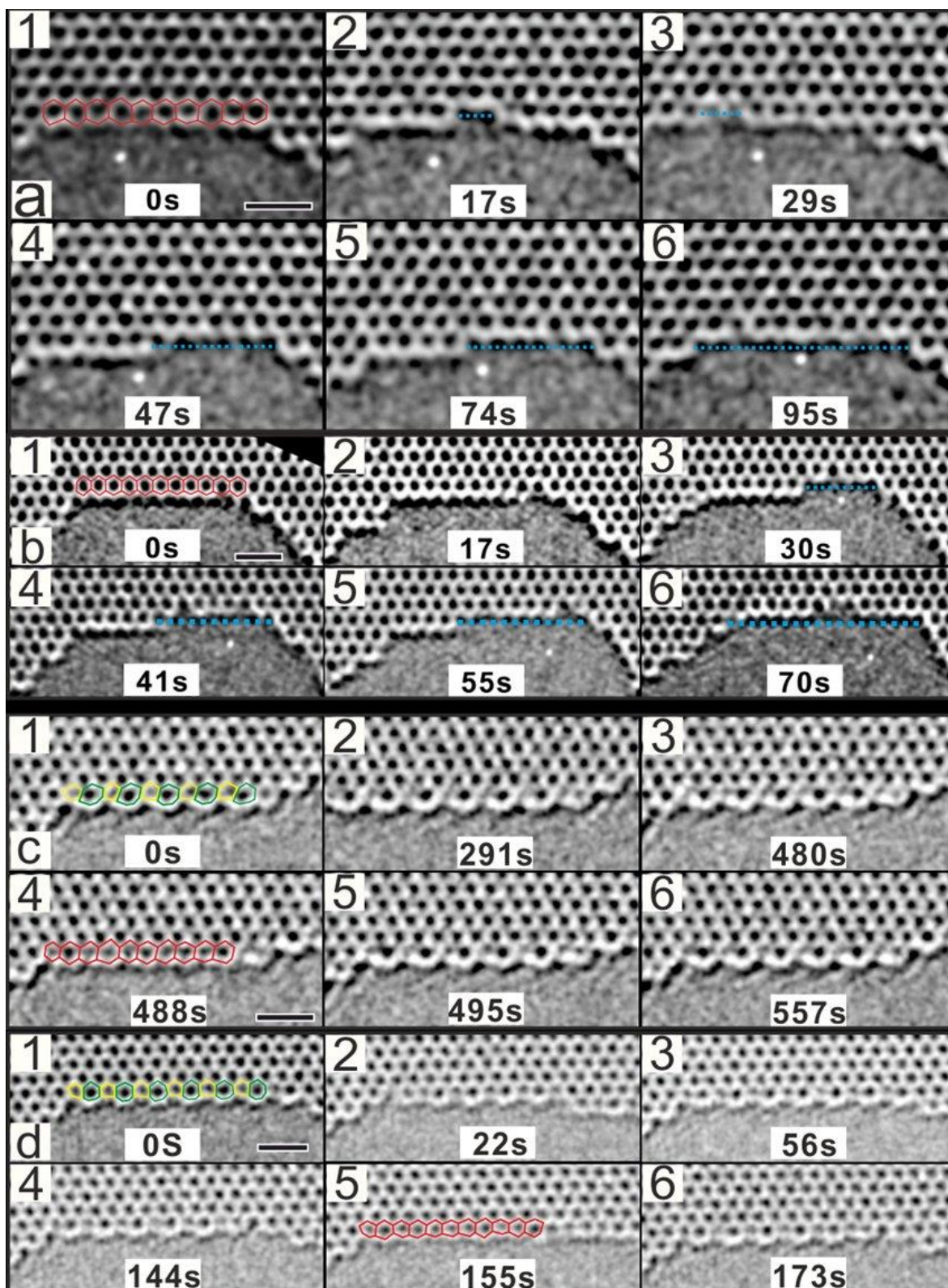
zag = > Rec. 5-7) of  $0.26\text{s}^{-1}$  and (Rec. 5-7 = > zig-zag) of  $0.12\text{s}^{-1}$ .<sup>33</sup> In our experiments at low temperature (RT and  $400^{\circ}\text{C}$ ), the edge configuration changes on a frame-to-frame basis due to the enhanced sputtering from chemical etching, illustrated in Figure 7 (a) and (b), the blue dashed lines indicate the number of atoms being etched away, by 95s at RT and 70s at  $400^{\circ}\text{C}$ , one row of zig-zag atoms has been removed. Most of the zig-zag edges are being etched away without having time to reconstruct, with only a small proportion remaining long enough to reconstruct into Rec. 5-7 configuration. Furthermore, the sputtering of atoms from a Rec.5-7 is found to often lead to the transformation back into a zig-zag edge, and reduces its contribution to the edge distribution statistics.

At high temperature ( $600$  and  $800^{\circ}\text{C}$ ), shown in Figure 7 (c) and (d), the outer most row of atoms remained stable for 557s and 173s respectively and the observation of the zig-zag edge was only for one frame, making its lifetime extremely short compared to that of the Rec.5-7. Whereas for the low-temperature measurements  $<400^{\circ}\text{C}$ , both edge states can be imaged for multiple frames, indicating much longer lifetimes. This can be understood by the mechanisms behind the flipping process. Below  $400^{\circ}\text{C}$ , the edges are flipped back and forth by electron impacts from the beam causing bond rotations. This is a stochastic process and would occur equally for both low temperature and high temperature measurements, but for the case of temperatures above  $600^{\circ}\text{C}$ , any time that the electron impacts flip the edge from Rec.5-7 to zig-zag, the thermal energy in the system rapidly flips it back to Rec.5-7 giving rise to a short lifetime of zig-zag edges. It is likely that the edge flipping process happens many times for the high temperature measurements, it is simply the case that it does not remain long enough in that state to image and we can't capture it. The edge flipping process happens on a much faster time scale than our image acquisition time.

As the temperature increase to  $600^{\circ}\text{C}$  and  $800^{\circ}\text{C}$ , chemical etching effect weakens dramatically, edge structure is much more stable. Combining with the effect temperature has on the flipping rate explained above, the zig-zag edges therefore has enough time to reconstruct itself into a more stable configuration at these two higher temperatures and results in a higher relative Rec. 5-7 ratio in the statistics. Ref 33 shows a very special occasion at room temperature that the graphene is

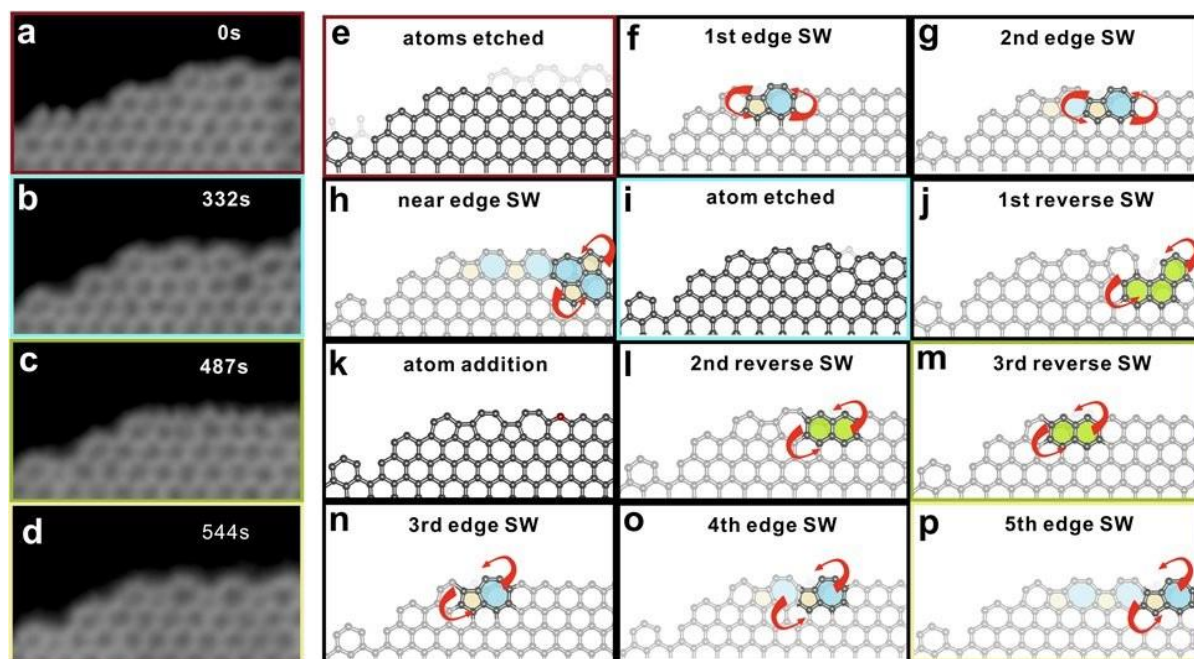


extremely clean around the edge area and no sputtering (atom loss) occurred during the entire reconstruction process, essentially emulating the high temperature behaviour in our experiment. Our experiment attempts to generalise the statistics to reflect the edge behaviour under all condition including the sputtering effect, therefore more than 1400 frames are used in the statistics.



**Figure 7. Temperature dependent edge etching effect.** Red, yellow and green solid lines represent hexagon, pentagon and heptagon respectively. The blue dashed lines indicate the row of carbons being lost due to electron sputtering. (a – d) are six time series frames of the same region of the graphene edge at RT, 400, 600, and 800 °C respectively. All scale bars = 1 nm

Probing graphene edges at high temperature using AC-STEM may provide further insights, because the STEM probe slowly raster-scans across the sample, rather than illuminating the entire edge as done in phase-contrast HRTEM (figures 2-7). Flipping an entire long edge from Rec.5-7 to zig-zag at high temperature requires multiple bond rotations, likely induced by multiple sequential electron scattering events. We expect that any local bond rotation randomly induced by the STEM beam will quickly relax back by the time the STEM probe reaches the next section of the edge and therefore the edges should be stable Rec.5-7 structures. Figure 8 shows an example, at 550 °C, where we see transitions between Rec.5-7 to zig-zag, initiated by atom sputtering at the edge, figure 8(b)-8(c). However it quickly relaxes back to Rec.5-7 as expected and remains stable in this configuration, figure 8(c)-8(d). Atomic models in figures 8(e)-8(p) schematically illustrate the structural transitions occurring between the STEM images.



**Figure 8. STEM study of zig-zag and Rec. 5-7 switching at 550°C.** (a)-(d) a time sequencing STEM images of graphene edges firstly being etched and then transformed into Rec. 5-7 configuration. (e)-(p)

Atomic models illustrating the reconstruction process shown in the STEM images. Carbon rings are highlighted to different colours in order to differentiate six-membered ring (green), five-membered ring (yellow) and seven-membered ring (blue). The red arrows demonstrate the direction of stone-wales rotation. The atomistic model that is outlined to different colours corresponds to the same atomic structure as shown in the STEM image that is outlined to the same colour.

## Conclusions

AC-TEM imaging of graphene edges has been carried out at four different temperatures (room temperature, 400°C, 600°C and 800°C). The statistical results show a dramatic transformation of edges between 400°C and 600°C; Armchair became the predominantly termination structure rather than zig-zag, and the Rec. 5-7 edge type also increased. This is caused by a combination effect of the reduction in chemical etching and increase in the flipping rate. The statistics of edge configuration at high temperature (600 and 800°C) therefore represent the true radiation stability order and agrees with theoretical calculations in the literature. We have also carried out STEM study of the detailed atom movements involved with this reconstruction process. This temperature dependent study of graphene edges provides insight into graphene edges on atomic scale and will shed light on future study of graphene nanostructure where edges become a major influence on its physical properties.

## Methods/Experimental

**Synthesis and transfer of graphene.** The graphene samples were grown by chemical vapour deposition, using a liquid copper catalyst as previously reported.<sup>45</sup> This was achieved by placing a high-purity copper sheet (Alfa Aesar, Puratonic 99.999% pure, 0.1 mm thick,  $\sim 1\text{cm}^2$ ) on top of a similar sized piece of tungsten (Alfa Aesar, 99.95% pure, 0.1mm thick). This was loaded into the quartz tube of the split-tube to vacuum and filled with argon. The gas flow was set to 100 s.c.c.m.  $\text{H}_2/\text{Ar}$  (20% gas mix) and 200 s.c.c.m. pure Ar, and the furnace was ramped to 1090°C, whereupon the sample was slid into the hot zone of the furnace. The sample was annealed for 30 minutes, after which the  $\text{CH}_4$  flow (1% gas mix in Ar) was set at 10 s.c.c.m. and the  $\text{H}_2/\text{Ar}$  flow reduced from 100

to 80 s.c.c.m., while being maintained for 90 minutes to obtain continuous film growth. The temperature was then reduced to 1060°C to allow the copper to solidify; a CH<sub>4</sub> flow was then reintroduced for 30 minutes to allow graphene to grow within cracks induced during the solidification process. After this, the CH<sub>4</sub> flow was disabled and the sample immediately removed from the furnace hot zone, allowing for rapid cooling in the H<sub>2</sub> and Ar atmosphere.

A (8% wt. in anisole, 495 molecular weight) PMMA was spin coated onto the graphene side of the sample at 4700 r.p.m. for 60s, and then cured at 180°C for 90s. The underlying tungsten was electrochemically etched away by attaching the sample to the anode and being fully immersed in 1M of sodium hydroxide solution. The copper was removed by floating the remaining samples in 1M of ammonia persulfate solution, until just a transparent PMMA/graphene film remained suspended on the surface. This was then cleaned by floating on fresh DI water 3 times for 10 minutes each time. The film was then transferred to a pre-fabricated heating holder (DENS Solutions DENS-C-30). After being left to dry for about 3 hours, the sample was baked on a hot plate for 15 minutes to remove water and improve sample adhesion with the wafer. The sample was then placed in a furnace at 350°C overnight to remove the PMMA scaffold.

**Transmission electron microscopy and image processing.** HRTEM was performed using Oxford's JEOL JEM-2200MCO field-emission gun TEM, using a CEOS imaging aberration corrector and an accelerating voltage of 80kV. A double Wien filter monochromator with a 7μm slit was used to reduce the energy spread of the electron beam to ~0.21eV. Data were recorded using a Gatan Ultrascan 4 K X 4K CCD camera with 2-5s acquisition times.

**Scanning Transmission Electron Microscopy.** A JEM 2100F with a cold field emission source and DELTA-type aberration correctors was operated at 60kV for STEM experiments. The beam current was estimated at around 40pA in 0.1nm probe.

**Heating holder.** To perform variable temperature experiments we used both a commercially available *in situ* heating holder from DENS Solutions (SH30-4M-FS) and a JEOL heating holder. In the DENSolutions holder, heating the sample was achieved by passing a current through a platinum

resistive coil imbedded in the TEM chip (DENS Solutions DENS-C-30). The resistance of the platinum coil is monitored in a four point configuration and the temperature calculated using the Callendar-Van Dusen equation (with calibration constants provided by the manufacturer).

**Image Processing.** Detailed image processing techniques employed are shown within Figure S3 of the supporting information.

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#### *Supporting Information Available*

Extra TEM images, study of hole opening rate, and image processing techniques employed is available free of charge *via* the Internet at <http://pubs.acs.org>.

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**Table of Content figure**

